IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	application of:	Vladimir Pavlovich	POPOV, et al.	
Seria	al No.: 10/542,1	23	Group No.:	2823
File	d: December 9, 2	005	Examiner:	Q. Jefferson
For: METHOD FOR PRODUCING A SILICON-ON-INSULATOR STRUCTURE				
Attorney Docket No.: U 015850-2				
P. O	nmissioner for Pater D. Box 1450 kandria, VA 22313-			
	CER	FIFICATE OF MAILING/I	TRANSMISSION (37 CFR 1.8a)
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			Signature	
Date:	March 26, 2008			

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